OIPE IAP38
FEB 28 2006
PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of	:	**Mail Stop Amendment**
Woo-Sung Jang	:	Group Art Unit: 1763
Application No.: 10/680,188	:	Examiner: Jeffrie R. Lund
Filed: October 8, 2003	:	

HIGH DENSITY PLASMA OXIDE FILM DEPOSITION APPARATUS HAVING A GUIDE RING AND A SEMICONDUCTOR DEVICE MANUFACTURING METHOD USING THE SAME

AMENDMENT AND REQUEST FOR RECONSIDERATION

U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated October 5, 2005, the Applicant amends the above-identified application and submits the following remarks and arguments:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the claims are reflected in the Listing of Claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 7 of this paper.